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PATENT APPLICATION

In re the Application of

JUL 1 2 2005

Ryoji HOSHI et al.

Attn: OIPE

Application No.:

10/520,099

Docket No.: 122336

Filed: January 4, 2005

For:

A SILICON WAFER FOR EPITAXIAL GROWTH, AN EPITAXIAL WAFER, AND

HE UNITED STATES PATENT AND TRADEMARK OFFICE

A METHOD FOR PRODUCING IT

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records in accordance with the Preliminary Amendment filed concurrently herewith.

egistration No. 30,024

Philip A. Caramanica, Jr. Registration No. 51,528

WPB:PAC/nxy

Date: July 12, 2005

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400

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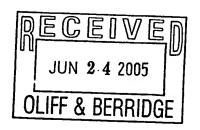


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FILING OR 371 DRAWINGS TOT CLMS IND CLMS APPL NO. ART UNIT FIL FEE REC'D ATTY.DOCKET NO (c) DATE 29 3 10/520,099 01/04/2005 1765 1350 122336 6

CONFIRMATION NO. 9147

25944 **OLIFF & BERRIDGE, PLC** P.O. BOX 19928 **ALEXANDRIA, VA 22320**



FILING RECEIPT OC000000016320304

Date Mailed: 06/22/2005

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

Shin-Etsu Handotai Co., Ltd., Tokyo, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/08671 07/08/2003

Foreign Applications

JAPAN 2002-204703 07/12/2002

Projected Publication Date: 09/29/2005

* PLEASE SEE PAGE 2 FOR CORKECTIONS TO THE TITLE!

Non-Publication Request: No

Early Publication Request: No

Title

Silicon wafer for epitaxial-growth; epitaxial wafer, and its manufacturing method

A SILICON WAFER FOR EPITAXIAL GROWTH, AN EPITAXIAL WAFER, AND AMETHOD FOR PRODUCING IT

Preliminary Class

117

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